REPAIR NO.  REPAIR NO.  188Y 2010 Senestics  First / Second Senestics  (For the confidence admined admined admined and OMR cheect should be handed over to hall investigates at the end of 25° minus.  (ii)  Part & A chould be asserved in OMR above within first 45 minutes and OMR cheect should be handed over to hall investigates at the end of 25° minus.  (iii)  Part & Bane Fart C chientle be asserved to have a volute.  Part B and Fart C chientle be asserved to have been considered by (A) Drude model  (iv) Drude product of the purpose of the proper of the productor of the productor of the proper of the commonly used semiconductor of the commonly of the commonly used semiconductor of the commonly of the comm	
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Page 2 of 3 13. 12. 20. 14. In linear four probe method, the tip of probe diameter is usually 18. 17. An example for O-D material is 16. C-V technique uses a metal-semiconductor junction (Schottky barrier) or a p-n junction or a 15. C-V measurements are capable 11. Optical processes directly involves 19 10. The semiconductor material, for which the lowest energy absorption takes place is 30 An ideal monochromator should have an probes are used to measure In Four probe technique, the outer two probes are used to apply (A) GaAs (C) Gash The absorption of photons in a photodiode is dependent on ( $\alpha_0$ ) (B) Properties ( $\alpha_0$ ) Charge carrier at junction concentration of charge carriers. (C) Photon The physical parameter that is probed in AFM resulting from different interactions is A spacing. (A) UV-Vis (C) Microwave 30 MOSFET to create a Voltage, current Bose-Einstein Potential Bonding Drift potential Larger Current, voltage Maxwell-Boltzmann Electron Charge Depletion region Electron - Hole pairs Small Nanosheet Nanowire statistics can be applied to identical indistinguishable particles of half spin. spectroscopy can be used to determine the concentration of the absorbs in a of yielding information about (B) Force (D) Amount of light (B) Properties of material 90 **B**B 日田 (D) Germanium (B) Silicon 更更 日田 (B) Fermi-Dirac (D) Bose-Dirac 99 90 absorption and emission Proton Neutron Current Gamma Zero Nanoparticle Nanorod Electron generation Hole generation Diffusion potential Smaller Voltage, Temperature Infinite Crystal structure Cooler Temperature, voltage narrow effective bandwidth the 14NA1-2/18PYB103J than the probe and inner two and 32.a.i. Describe the 31.a. 21. 22. 23. 24. 27. b.i. b.i. ii. Write a note on I-V characteristics of a junction diode. Ď. Write any two advantages and disadvantages of LED. Write a note on drift current. Explain nonequilibrium properties of carriers. technique. microscope.

## Answer ANY FIVE Questions $PART - B (5 \times 4 = 20 Marks)$

- Explain indirect band gap materials with the help of E-K diagram.
- Write a short note on organic light emitting diodes.
- Explain optical absorption and recombination process.
- Explain the working of two point probe technique.
- Write a note on applications of carbon nanotubes

## $PART - C (5 \times 12 = 60 \text{ Marks})$ Answer ALL Questions

28.a.i. Define Density of states, Derive an expression for density of states of a semiconducting (9 Marks)

(3 Marks Scanned by CamScanner

Write any two success and failures of classical free electron theory

What is effective mass? Derive an expression for effective mass of an electron. (10 Marks)

Find the temperatures at which there is 1% probability of a state with energy 0.5 eV abov (2 Marks

Define extrinsic semiconductor. Derive an expression for Fermi semiconductor. Explain the variation of Fermi level with temperature energy in N-typ (4 Mark (8 Marks

Define P-N junction. Explain the biasing concepts in P-N junction

What is Light emitting Diode? Describe the principle, construction and working of a LE (10 Mark

Explain the absorption and emission process with necessary theory and derive the relati between Einstein's co-efficients.

Derive an expression for joint density of states and also density of states of photons.

Describe-linear and Vander Pauw's four point probe technique for electrical measurement

Describe the principle, construction and working of Deep level Transition spectroscopy.

(8 Ma

(4 Ma

fabrication of Carbon Nanotubes by Physical vapour Deposition (P (8 Ma

Write a short note on powder XRD technique.

With a neat sketch, explain the working concept, source and utilization of scanning elec-

Page 3 of 3 14NA1-2/18PYB1

(1) the the conference of the	(b) (1) Expur 3/10 8 (1) (1) (18 +3 (1) (1) (1) (1) (1) (1) (1) (1) (1) (1)	11. a. Describe the Linear and Vander Panw Four Point Probe technique for electrical measurements.  (OR)  b. What are the fundamental laws of absorption? Describe the principle, construction and working of UV Visible Spectrophotometer.  32. a.i. What are Carbon nanotubes (CNT)? Mention the properties of CNTs. (4 Marks)  ii ii. Describe the fabrication of CNT's by Physical Vapor Deposition (PVD). (8 Marks)  b.i. Describe the principle, construction and working of Scanning Electron Microscope (SEM).  ii. Write a note on Heterojunctions. (8 Marks)	b.i. What is a Light Eminting diode (LED)? Describe the principle, construction and working of LED.  ii. Write a note on diffusion and drift current.  30. a. Explain the absorption and emissions processes with necessary theory and hence derive the relation between Einsteins coefficients.  (OR)  b.i. Describe the theory of Drudes model and hence derive the expression for electrical conductivity.  ii. Mention any two applications of photovoltaic effect.  (2 Marks)	
6. When light impinges upon a semiconductor to create electron – hole pairs, some of the carriers are collected at the contact which leads to  (A) gain (C) amplification (D) biasing  7. Which type of material is obtained when intrinsic semiconductor is doped with pentavalent impurity? (A) N-type semiconductor (C) P-type semiconductor (C) P-type semiconductor (D) Insulator  Fapo 1 of 4	is the state at which the probability of electron occupation is ½ at any temperature above 0K.  (A) Valence level (C) Conduction level (C) Conduction is ½ at any fermi level (C) Conduction in a periodic potential is accelerated relative to the lattice in an electric field or magnetic field, then the mass of the electron is called the (A) Rest mass (C) Zero mass (C) Zero mass (D) Accelerated mass (C) Zero mass (E) I Light Emitting diode (D) Transistor (D) Transistor	Time: Three Hours  PART - A (20 × 1 = 20 Marks)  Answer ALL Questions  1. The average distance travelled by an electron between two successive collisions in the presence of applied field is called  (A) Collision time (C) Wave number  2. The bend gap is called	Reg. No.  B.Tech. DEGREE EXAMINATION, NOVEMBER 2018  First Semester  18PYB1031 - PHYSICS: SEMICONDUCTOR PHYSICS (For the condidates admitted the ing the academic year 2018-2019)  Part - A should be answered in OMR sheet within first 45 minutes and OMR sheet should be handed over to hall invigilator at the end of 45th minute.  (ii) Part - B and Part - C should be answered in answered booklet.	Da-26 Josephono.

